

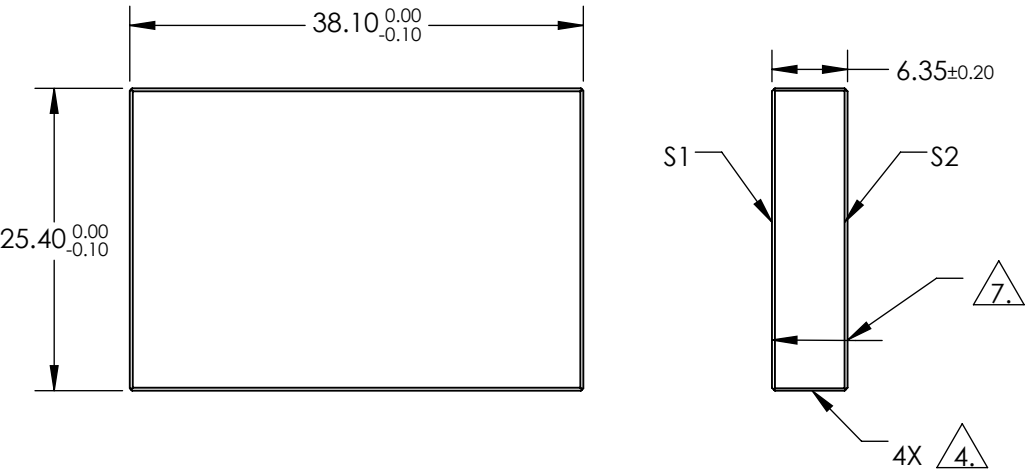
NOTES:

1. SUBSTRATE:
Fused Silica
2. SURFACE S1 TO BE PARALLEL TO SURFACE S2 TO WITHIN <3 ARCMINS
3. COATING (APPLY ACROSS COATING APERTURE)

S1: R(ABS) >99.8% @ 266nm
DAMAGE THRESHOLD,
PULSED: 15 J/cm² @ 1030nm, 20ns, 20Hz

S2: NONE

4. FINE GROUND SURFACE
5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
7. ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS TOWARDS SURFACE S1



**FOR INFORMATION ONLY:
DO NOT MANUFACTURE
PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2				
SHAPE	PLANO	PLANO	THIRD ANGLE PROJECTION ALL DIMS IN mm Edmund Optics® 25.4 x 38.1mm 266nm 0-45°, Nd:YAG Laser Line Mirror DWG NO 39592 SHEET 1 OF 1			
SURFACE QUALITY	10-5	COMMERCIAL POLISH				
SURFACE FLATNESS	0.10 WAVE	N/A				
MIN CLEAR APERTURE	21.59 x 32.39	N/A				
MIN COATING APERTURE	21.59 x 32.39	N/A				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED				